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Attention: Mail Stop AF  
Response Under 37 C.F.R. § 1.116  
Expedited Procedure Requested  
Examining Group 2814

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.2444-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Hiroshi TOYODA, et al. ) Group Art Unit: 2814  
Application No.: 10/600,568 ) Examiner: Weiss, Howard  
Filed: June 23, 2003 )  
For: METHOD OF MANUFACTURING )  
SEMICONDUCTOR DEVICE )  
INCLUDING TWO-STEP )  
POLISHING OPERATION FOR CAP )  
METAL )

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed June 18, 2004, with a period for response extending through September 20, 2004 (September 18, 2004 being a Saturday), Applicants propose amending the application as follows and request the Examiner's reconsideration in view of the remarks that follow:

**Amendments to the Claims** are reflected in the listing of claims beginning on page 2 of this paper.

**Remarks** begin on page 4 of this paper.